



In re Application of: P. Loges, et al.

Serial No:

10/074,188

Filing Date:

February 12, 2002

Title:

FILAMENT FOR RADIATION SOURCE

Examiner:

Fastovsky, Leonid M.

Art Unit:

3742

Docket No:

56326-041 (IOPL-119)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 2313-1450 on the data indicated below.

Date: 44505

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT D

Sir:

In response to the Office Action mailed May 12, 2005, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.